



Attorney Docket # 5300-23

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

John A ROUSE et al.

Serial No.: 09/994,563

Filed: November 27, 2001

For: Reduction Of Aberrations Produced By Wien  
Filter In A Scanning Electron Microscope And  
The Like

Examiner: El Shammaa, M.  
Group Art: 2881

I hereby certify that this correspondence is being  
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Thomas Langer

Name of applicant, assignee or Registered Representative

Signature

February 3, 2004

Date of Signature

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COMMUNICATION FORWARDING FORMAL DRAWINGS

S I R:

Responsive to the Notice Of Allowance dated November 6, 2003, enclosed are two sheets  
of formal drawings (Figs. 1 to 2) as requested.

In the event that any fees or charges are deemed necessary in connection with the  
application at the present time, the same may be charged to our Deposit Account No. 03-2412.

Respectfully submitted,  
COHEN, PONTANI, LIEBERMAN & PAVANE

By

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Dated: February 3, 2004